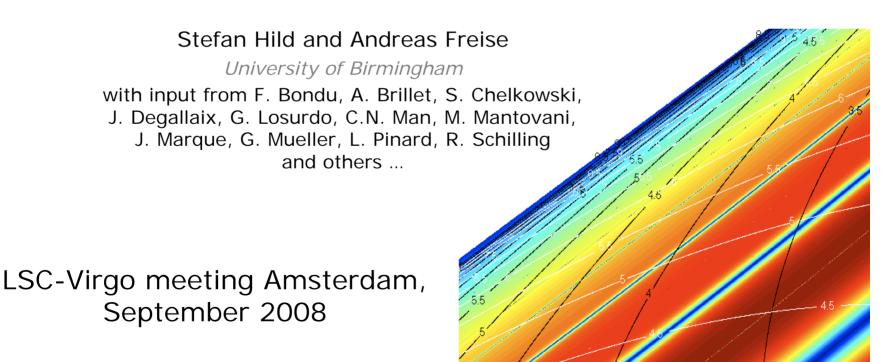


On Aspects of the Advanced Virgo Arm Cavity Design







The Context

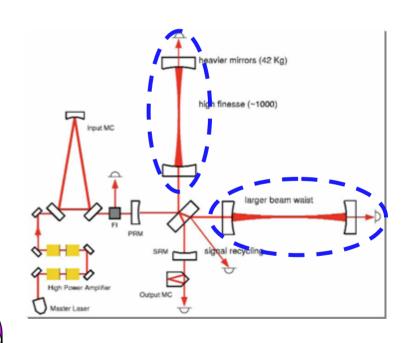
- Advanced Virgo design is organized in several subsystems.
- ▶ I work on the subsystem: "Optical simulation and Design" (OSD) subsystem-manager: A. Freise
- One of the primary tasks of the OSD-subsystem is the Advanced Virgo Arm Cavity Design.





Arm Cavities: The Core of GW Detectors

- In principle arm cavities are rather simple objects, consisting of just two mirrors and a space between them.
- In reality one has to carefully choose the characteristics of the arm cavities:
 - Detector sensitivity and bandwidth.
 - Actual arm cavity design sets constraints for other subsystems.
 - Design of other subsystems sets constraints for the arm cavity design.





Characteristics of the Arm Cavity to be chosen

- Beam geometry (waist position)
- Beam size at the test masses
- Radius of curvature of the test masses
- > Finesse of the arm cavity

Brief overview of the principle considerations

Wedges or Etalon



... going a bit more into detail ... (Discussion of various requirements and constraints)





Beam Geometry

- Where to put the waist inside the arm cavity?
 - Initial detectors have the waist close/at the input mirrors
- Advanced detectors: Move waist towards the cavity center.
 - Larger beam at input mirror
 - Lower overall coating Brownian noise
 - BUT: much larger beams in the central interferometer
 - may need larger BS
 - much larger optics for input and output telescope
 - Non-degenerate recycling cavities might help





Beam Geometry

Intuitively one would think the lowest coating noise is achieved when beam waist is at the center of the cavity (=> equal beam size at ITM and ETM),

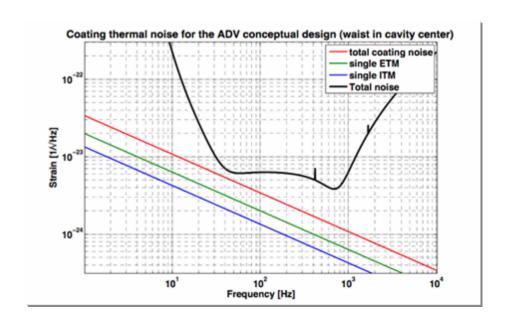
BUT:

Coating noise for ITM and ETM are different, due to their different number of coating layer:

$$\overline{v} = C(S_T + \gamma^{-1}S_S),$$

J. Agresti et al (LIGO-P060027-00-Z)

For equal beam size ETM has higher noise.



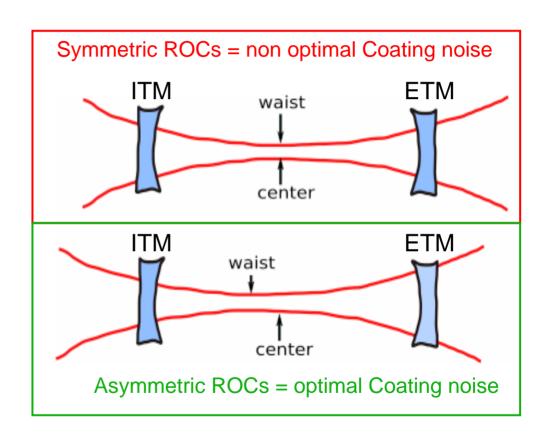






Optimal Waist Position

- In order to minimize the thermal noise we have to make the beam larger on ETM and smaller on ITM.
- Equivalent to moving the waist closer to ITM.
- Nice side effect, the beam in the central central area would be slightly smaller.





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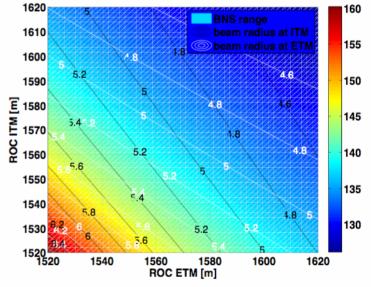
Beam Size

- Principle Rule:
 - The larger the beam the better the detector sensitivity

Larger beams make nearly everything else more complicated /

more expensive.

- Advantages of large beams:
 - Reduced thermal noise of test masses (especially coating Brownian)
 - Slightly reduced contribution from residual gas pressure
 - Reduced thermal lensing
- Disadvantages of large beams:
 - Higher clipping losses
 - Larger test masses (especially BS, because of 45deg angle)
 - Larger apertures are required (vacuum system, actuators, etc)
 - Large telescopes (input, output, pick-off beams)
 - More sensitive to ROC deviations





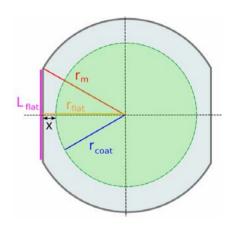
How to decide on Beam Size?

- Order of constraints:
 - Mirror weight (from suspension)
 - 2. Aspect ratio of mirror
 - 3. Coating size
 - Choose affordable losses



- Detector sensitivity
- Clipping losses inside the arm cavity (mirror/coating size)
- Clipping losses inside recycling cavities (actuator geometry, BS size)
- Scattered light noise contribution of the clipped light
- Cavity stability (see following slides)
- In the end we will probably choose a beam radius (1/e^2 in power) of about 5.5 to 6.5cm.

More detail in Hild et al: VIR-038B-08



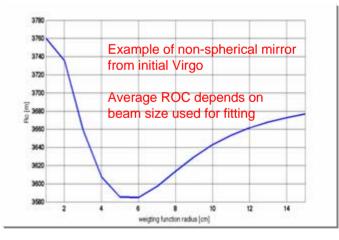






Cavity Stability and Choice of ROCs

- ROCs and beam size are connected.
- We want ROCs that give stable cavity:
 - Account for potential manufacturing accuracy
 - AdVirgo example: L = 3000m, beam radius at ITM and ETM = 6cm => ROCs of 1531m are required.
 - Deviation of only a few ten meters can make cavity instable.
 - Additional problem: polished spheres are not spherical.



- Avoid resonance of higher order optical modes
 - Use mode-non-degeneracy as figure of merit





Cavity Stability and Choice of ROCs

- Definition of mode-nondegeneracy:
 - Gouy-phase shift of mode of order I+m:

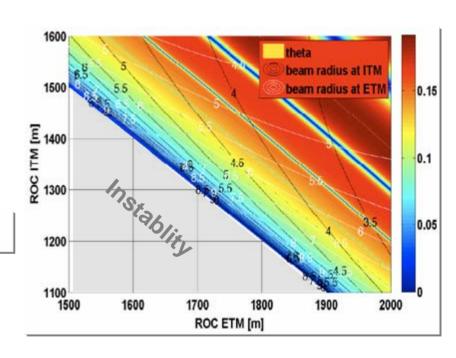
$$\phi_{l+m} = (l+m)\frac{1}{\pi} \arccos \sqrt{(1-\frac{L}{R_{c,i}})(1-\frac{L}{R_{c,e}})}.$$

Mode-non-degeneracy for a single mode is:

$$\Psi_{l+m}(L, R_{c,i}, R_{c,e}) = |\phi_{l+m} - \text{round}(\phi_{l+m})|.$$

⇒ Figure of merit for combining all modes up to the order N:

$$\Theta_N(L, R_{c,i}, R_{c,e}) = \frac{1}{\sqrt{\sum_{k=1}^N \frac{1}{\Psi_k^2} \frac{1}{k!}}}$$

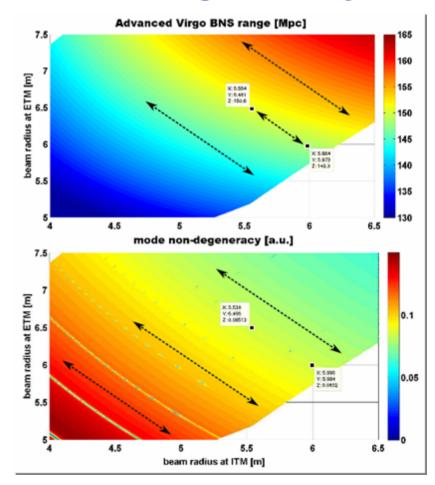






Choice of ROCs/beam size: Sensitivity vs Mode-non-degeneracy

- In general mode-nondegeneracy and sensitivity go opposite.
- Asymmetric ROCs are beneficial:
 - ⇒ For identical mode-non-degeneracy (parallel to arrows in lower plot) we can increase sensitivity (parallel to arrow in upper plot) by going towards the upper left corner.
 - This means making beam larger on ETM and smaller on ITM.







Arm Cavity Finesse

- Advantages of higher finesse:
 - Reduced noise coupling from MICH to DARM
 - Less thermal load in central interferometer
- Disadvantages of higher finesse:
 - More sensitive to losses inside the arm cavities
 - ⇒ Increased coating Brownian noise of the ITM (due to more required coating layers
 - Power problems (parametric instabilities)?
- In the end we will probably go for a finesse between 400 and 700.



Characteristics of the Arm Cavity to be chosen

- Beam geometry (waist position)
- Beam size at the test masses
- Radius of curvature of the test masses
- > Finesse of the arm cavity

Brief overview of the principle considerations

Wedges or Etalon



... going a bit more into detail ... (Discussion of various requirements and constraints)





Wedges vs Etalon

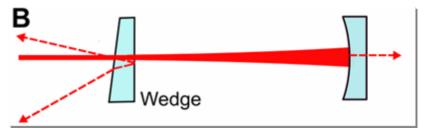
Input mirror etalon:

- Initial Virgo has no wedges in the input mirrors
- The etalon effect could be used for adjusting the cavity finesse (compensating for differential losses)
- If etalon effect is not controlled it might cause problems



Input mirror with wedge:

- Used by initial LIGO
- Reflected beams from AR coating can be separated from main beam => pick-off beams provide additional ports for generation of control signals.
- No etalon effect available.





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Possible design option: Wedges at input mirrors and etalon effect at end mirrors



- Wedge at input mirrors:
 - Allows for additional pick-off beams
- Use etalon effect at end test mass.
 - Tune etalon to balance arms => reduce noise couplings => might speed up commissioning
 - ⇒ Tune etalon to change readout quadrature in DC-readout.
 - ⇒ Replace AR-coating by a coating of about 10% reflectivity.
 - Ideally use a curved back surface (same curvature as front).

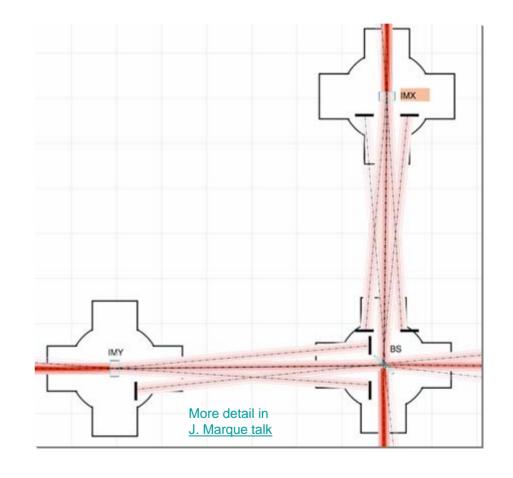






Wegdes at Input Mirrors

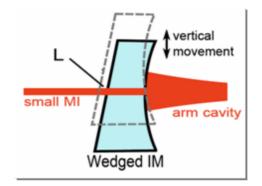
- Need a wedge large enough to separate beams within about 5 meter (distance ITM to BS).
- For 6cm beam radius a wedge of about 1.5 deg is required.
- High hardware impact (larger vacuum tube in centeral IFO, more optical elements)





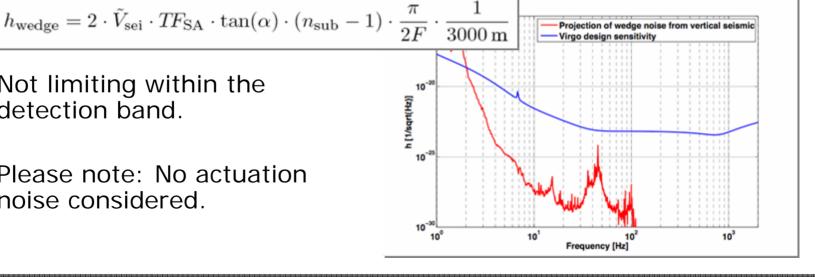
Differential Arm Length Noise from vertical Movement of wedged Input Mirrors

- Lateral movement of a wedged mirror cause length sensing noise.
- Need to do a projection of seismic noise to DARM:



More detail in Hild et al: VIR-037A-08

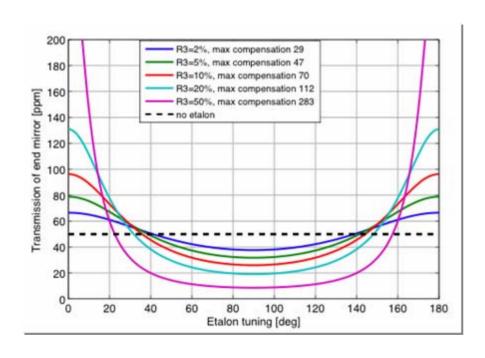
Please note: No actuation noise considered.

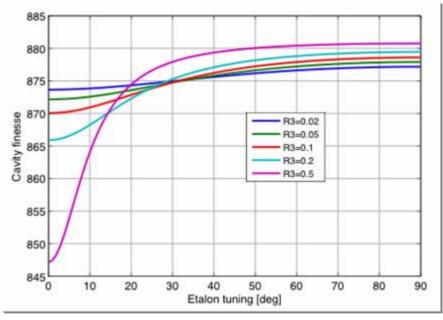






Balancing Range due to Etalon Effekt





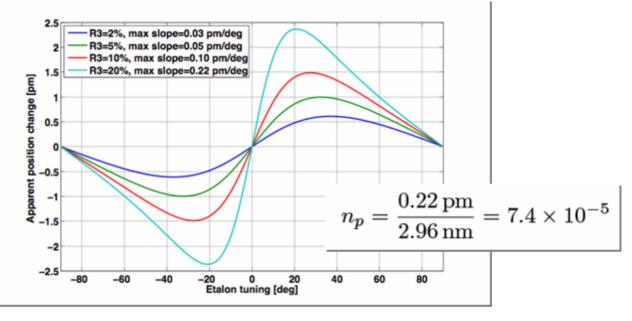
- > Examples of figures of merit:
 - Transmittance of end mirror (etalon)
 - Finesse of arm cavity







Etalon changes Optical Phase



- When changing the etalon tuning the optical-phase changes as well. (noise!)
- The two etalon surfaces build a compound mirror, whose apparent position depends on the etalon tuning.





Requirement for Temperature Stability of Etalon Substrate

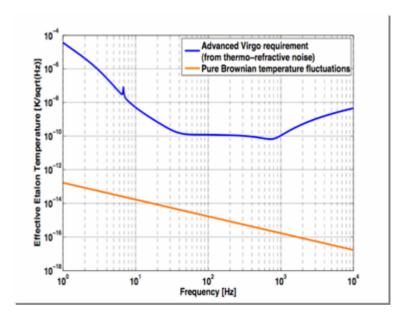
Certain temperature stability of Etalon substrate required to not spoil AdV sensitivity

$$\tilde{h}_{\mathrm{adv}}(f) = \tilde{T}_{\mathrm{req}}(f) \cdot \frac{dn}{dT} \cdot l_{\mathrm{eta}} \cdot n_p \cdot \frac{1}{L},$$

Can compare this requirement to substrate thermal noise

$$\tilde{T}_{\text{mirror}}(f) = \sqrt{\frac{4k_b T^2 \kappa}{(\rho C)^2 l_{\text{eta}}} \frac{1}{\pi R_b^4 (2\pi f)^2}},$$

- Not limiting.
- Please note: Did not consider technically driven temperature fluctuations.



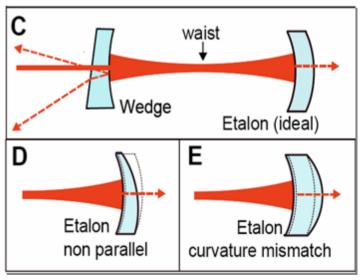
More detail in Hild et al: VIR-058A-08





Optical Design: Check System Integrity for Deviations from Specs

- ➤ A deviation in the relative misalignment (parallelism) and relative curvature of the two etalon surfaces:
 - ⇒ Imperfect wave front overlap...
 - Reduces tuning range ...
 - Beam shape distortions ...
- > Two methods for analysis:
 - FFT based code (Waveprop)
 - Coupling coefficients







FFT-simulation of a Non-Perfect Etalon

- Using R. Schilling's WaveProp, http://www.rzg.mpg.de/~ros/WaveProp/
- Cross checking with DarkF. DarkFstatus 08 03 2006.ppt
- Parameters:
 - ⇒ Field: 256x256
 - Computing 3000 roundtrips
 - End mirror front:
 - 50ppm transmission
 - End mirror back:
 - Varying three parameters
 - Reflectance
 - Misalignment (parallelism)
 - Curvature mismatch

```
I wise of the grid in one dimension [m]
lambda - 1.064e-6
                                                                | light wavelength [m]
dist - 3000.
                  - .03517543
                                                                          ! rudius of initial boum [m]
m1Ndx - 0.175
                                                                I radius of cavity input mirror M1 [1/m]
I curvature of cavity input mirror [1/m]
I amplitude reflectance of cavity input mirror
=1%c --1./1910.
                 - surt(0.9929)
m2fr%r - sqrt(0.99995)
m2fr%n2- 1.44963
                                                                I refractive index of end mirror substrate
                                                                 | redius of year surface of M2 [1/e]
=2b%c = 0.
=2b%c = sart(0.20)
                                                                I curvature of rear surface of H2 [1/m] I amplitude reflectance of rear surface of H2
m2b%n1 - m2fr%n2
                                                                I refractive index of end mirror substrate
call wp_init(nx, sog, lembda, fftw-'m')
coll wp_setup(m1)
                                                                                         I set us covity input mirror
call wp_setup(m2fr)
                                                                                         I set up covity and mirror (front surf.)
call wp_setup(m2ft,'tf')
                                                                                       ! set up cavity and mirror (front surf.)
call wp_setup(m2b)
                                                                                         I set up cavity and mirror (back surf.)
coll wp_hgmode(psi_in,wi,-miNc,pw-1-0.99295) | generate initial field
  do (ph-0, nph
                                                                                            do uph phase values for substrate
     phi-phi+(368./nph)*deg
                                                                                       I next phase for substrate cavity
I build array representing on X axis
I set up and clear cavity field
     call wp_setup(psi_ca)
call wp_setup(psi_su,m2fr%n2)
                                                                                       I set up and clear substrute field
     do int-0, not
                                                                                         I do not cound trips
          w(irt)-real(irt)
                                                                                         I build array representing on X oxis
          coll wp_reflect(psi_co,m1)
                                                                                         | reflect at near mirro
                     coll wp_reflect(psi_su, #2b, phi-phi) | reflect at back surface of a coll wp_transmit(psi_su, #2ft, "b", psi_out-psi_ou) | swit though M2 call wp_reflect(psi_su, #2ft, "b" reflect at front surface of M call wp_interfere(psi_ou, psi_co, psi_co) | interf. of ca with surface of M call wp_interfere(psi_ou, psi_co, psi_co) | interf. of ca with surface of M call wp_interfere(psi_ou, psi_co) | interf. of ca with surface of M call wp_interfere(psi_ou, psi_co) | interf. of ca with surface of M call wp_interfere(psi_ou, psi_co) | interf. of ca with surface of M call wp_interfere(psi_ou, psi_co) | interf. of ca with surface of M call wp_interfere(psi_ou, psi_co) | interf. of ca with surface of M call wp_interfere(psi_ou, psi_co) | interf. of call wp_interfere(psi_ou, psi_co) | interfere(psi_ou, ps
           call wp_propagate(psi_ca,dist) | propagate to near mirror
     pactiph)-pathet)
                                                                                       I store final cavity power
call wp_plot3d(psi_in,4, 'Imput f(mld',zoom-2.)
                                                                                                                                       I plot imput field
```



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Analytic Approximations using Higher-Order Modes

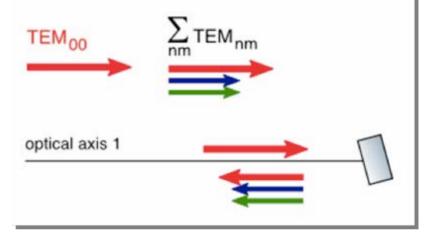
- Reflection at a (slightly) misaligned component can be characterised by scattering into higher order TEM modes
- This model is valid for misalignments below half the diffraction angle (paraxial approximation)
- The amplitude in the outgoing fields is given by coupling coefficients k_{nmnm}

$$a_{nm} = k_{00nm} \ a_{00}$$

For small misalignments the coupling coefficients k_{nmnm} can be approximated. The amount of light which remains in a TEM₀₀ mode is given by:

$$k_{0000}(q,\gamma) = \exp\left(-\frac{\pi|q|^2 \sin^2(2\gamma)}{2\lambda \Im(q)}\right)$$

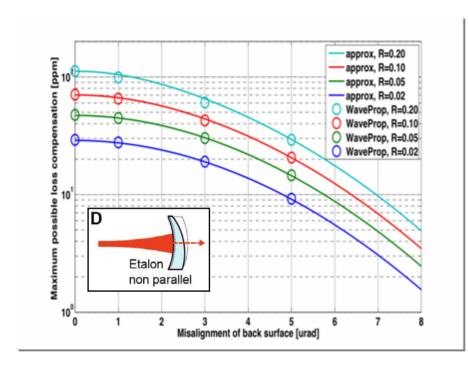
(q is the Gaussian beam parameter of the light at the mirror)

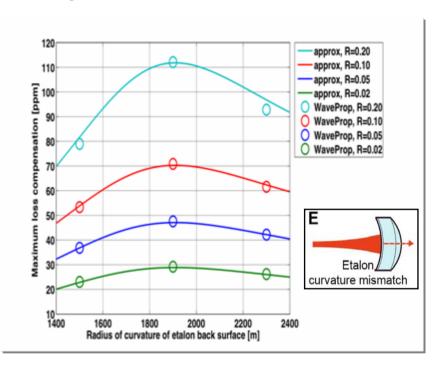






Tuning Range of imperfect Etalon





- Requirements for Etalon manufacturing accuracy:
 - Parallelism better than a few urad.
 - ROC deviation: uncritical

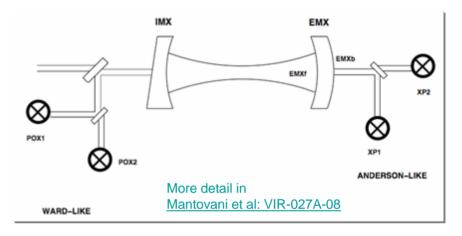


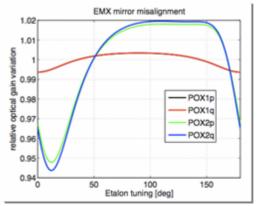
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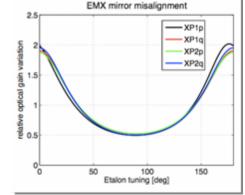


Influence of Etalon Tuning to other Subsystems: Example Alignment

- Evaluation of global alignment sensing and control.
- Simulated Ward-technique and Anderson-technique.
- For perfect etalon: No surprises.
- For non perfect etalon:
 - Coupling of etalon rear surface misalignment is 4 to 5 orders below etalon front surface misalignment.
 - Amount of first order optical modes inside the arm cavity origination from etalon imperfections is found to be negligible.











Summary

- Presented overview of how to choose the main characteristics of the Advanced Virgo arm cavity.
- More detailed analysis for wedges vs etalon:
 - Presented potential design (wedged ITM, etalon at ETM)
 - Presented requirements for:
 - Seismic isolation (wedge)
 - Temperature stability of etalan (optical phase noise)
 - Manufacturing accuracy of the etalon
 - Checked for negative implications of other subsystems:
 - Alignment sensing and control
- Publication on the arxiv:

Hild et al: "Using the etalon effect for in-situ balancing of the Advanced Virgo arm cavities" arXiv:0807.2045

